



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Saka et al.

Application Number: **10/029,080**

Filed: **December 21, 2001**

For: **In-Situ Method and Apparatus
for End Point Detection in
Chemical Mechanical Polishing**

Group Art Unit: **2877**

Examiner: **M. P. Stafira**

**PETITION FOR TWO MONTH
EXTENSION OF TIME**

CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on September 18, 2003.

Signed: _____

Lori Cox

Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.136(a), an extension of time of:

	<u>Large Entity</u>	<u>Small Entity</u>
One Month	// \$110.00	// \$55.00
Two Months	/X/ \$410.00	// \$205.00
Three Months	// \$930.00	// \$465.00
Four Months	// \$1,450.00	// \$725.00

This Petition is hereby requested to respond to the Office Communication mailed April 18, 2003.

Please charge any additional fees or credit any overpayment to Deposit Account 50-2319 (Order No. A⁶9174-1/MSS/MDV (463035-29)).

Respectfully submitted,

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